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(P E 1110-98029 PATENT

JUN 1 9 2008

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Appl. No.

10/589,587

Applicant

INAGAKI et al.

Filed

16 August 2006

Art Unit

1792

Examiner

KUNEMUND, Robert M.

Docket No.

1110-98029

Customer No.:

24628

Title

METHOD FOR

MANUFACTURING SINGLE CRYSTAL SEMICONDUCTOR Confirmation No.: 2705

CERTIFICATE OF MAILING BY FIRST CLASS MAIL (37 CFR 1.8)

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as First Class Mail in an envelope addressed to: Mail Stop Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313, on the date below.

17 June 2008 (Date)

<u>AMENDMENT</u>

Mail Stop Amendment Commissioner for Patents P.O. Box 1450 Alexandria, Virginia 22313-1450

Dear Sir:

The Office Action of March 19, 2008 has been carefully reviewed and the following amendments and remarks are made in response thereto: